

## **SENSOR FABRICATING METHOD**

### **ABSTRACT OF THE DISCLOSURE**

The present invention provides methods for fabricating a sensor on a substrate having a pair of electrodes. The methods are especially amenable to broad variations amongst individual sensor on a single substrate. The intra-sensor variation within the array can be achieved in various fashions. The method provide intra-sensor variation using quantitative and qualitative differences in each sensor.

10 SF 1219261 v1

09647825 - 050204